



## Nano and MEMS Sensors

Guest Editor:

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### Message from the Guest Editor

Dear Colleagues,

The manufacturing and integration of autonomous and embedded sensors through a combination of micro- and nanosystem technologies have been revolutionizing self-powered, high bandwidth devices for advance manufacturing (AM), artificial intelligence (AI), and IoT.

More specifically, nano and MEMS sensors are the building blocks for a vast range of applications, from continuous real-time health (wearable) and environmental monitoring (gas, pressure, temperature, etc.) to enabling embedded mobile Internet services (wireless), including smart/connected cars and unattended vehicles (UAV) (inertial). As these devices have numbered in the tens of billions, the potential for disruptive innovation has been immense.

For further information, please visit [mdpi.com/journal/sensors/special\\_issues/Nano\\_MEMS\\_Sensors](http://mdpi.com/journal/sensors/special_issues/Nano_MEMS_Sensors).

Prof. Dr. Mustafa Yavuz  
*Guest Editor*





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